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	Application Number		09698479
	Filing Date		2000-10-30
	First Named Inventor	Vance	Bergeron
	Art Unit		1796
	Examiner Name	Willian	m K. Cheung
	Attornov Docket Number		9430 004 LICCD00

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Horney Docket Number		8439 004 USCP00

ľ	4	Notice of Allowance mailed November 22, 2010 in US Patent Application No. 11/966675 to Yeung et al.	
	3	Japanese office action mailed June 15, 2010 from JP pat. app. no. 2000-619981 to Yeung et al.	
	2	Translation of Amendment of December 15, 2010 in response to Japanese office action mailed June 15, 2010 from JP pat app. no. 2000-619981 to Yeung et al.	
	1	Transiation of Amendment of November 17, 2010 in response to Japanese Office Action mailed May 18, 2010 from JP patent application no. 2000-620033 to Bergeron et al.	×

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